

PCN-000530

Date: July 10, 2019

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Semtech Corporation 20	00 Flynn Road, Camarillo CA 9	03012	
Semtech Canada Corporation, 4281 Harvester Road, Burlington, Ontario L7L 5M4 Canada			
Semtech Irvine, 5141 California Ave., Suite 100, Irvine CA 92617			
Semtech Neuchatel Sarl, Route des Gouttes d'Or 40, CH-2000 Neuchatel Switzerland			
Semtech Bristol - EMEA Limited, Block B, St James Court, Great Park Road, Bristol BS32 4QJ, UK			
Semtech Corpus Christi SA de CV, Carretera Matamorros Edificio 7, Reynosa, Tamaulipas, Mexico 88780			
	esource Drive, Suite 121, Plar		
Part Number(s) Affect	ed:	Customer Part Numb	er(s) Affected: 🖂 N/A
NT20067-GRP6			
1T20067-WP			
NT20R67-GRP6			
NT20R67-DTF8S			
NT23L50-GRP6			
NT23L50-WP			
NT24L50-GRP6			
NT24L50-WP			
NT24L50-DTF8S			
NT25L50-GRP6			
NT25L50-WP NT24L55-WP			
NT25L51-GRP6			
NT25L51-WP			
GN25L51-WP GN25L53-GRP6			
GN25L53-GRP0 GN25L53-WP			
NT28L52-GRP6R			
NT28L52-WP			
GN25L53B-GRP6			
GN25L53B-WP			
NT32012-DTF8S			
NT25L59-GRP6			
Description, Purpose a	and Effect of Change:		
••	tends to move all its Fle		
There is no change in	test systems, test prog	rams or test hardware	used.
Change Classification	🗌 Major 🛛 Minor	Impact to Form, Fit,	🗌 Yes 🛛 No
5		Function	
Impact to Data Sheet	🗌 Yes 🛛 No	New Revision or Date	⊠ N/A
mpact to Performance	e, Characteristics or Re	liability:	
	ance, characteristics	or reliability is expect	ed as a result of this
change.			

Semtech Corporation • 200 Flynn Road • Camarillo • Ca • 93012 • Phone +1 (805) 498-2111



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Implementation Date	Oct 10 2019	Work Week	N/A
Last Time Ship (LTS) Of unchanged product	N/A	Affecting Lot No. / Serial No. (SN)	N/A
Sample Availability	N/A	Qualification Report Availability	N/A
 KYEC Chu-Nan site details Validation report PRODDOC020200 Please see following pages. 			
Validation report PF	RODDOC020200		
Validation report PF	CODDOC020200 g pages.	Authority	
Validation report PF	CODDOC020200 g pages.		



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Purpose: KYEC relocation plan of production testers from Hsin-Chu to Chu-Nan.
Scope: All iFLEX series testers qualified to run Semtech products.
Reason for the Change In Hsin-Chu site capacity is limited by available space. It is difficult to add new equipment and increase test capacity.
Benefits: KYEC Chu-Nan can add new test equipment to meet increased customer capacity needs.
Some products are assembled in KYEC Chu-Nan. This change will eliminate transfer time between two sites if wafer probe & assembly are both done in Chu-Nan site.



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Chu-Nan site background

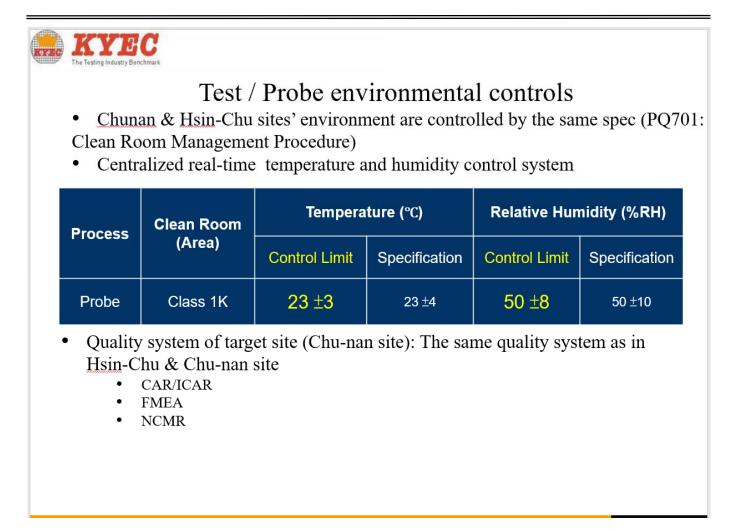
- Chu-Nan CH-2 factory has been in operation for about 13 years, since 2006.
- Number of employees: 625
- Certifications: ANSI/ESD S20.20, IECQ-QC080000, ISO 14064, IATF 16949:2016, TAF Lab ISO 17025, ISO 9001:2015, TL 9000(2015), OHSAS 18001:2007, ISO 14001:2004, etc.
- Risk assessment: Test results will be validated through correlation between current site and target site.
- Chu Nan site is already qualified site for wafer probing and final testing for over 100 Semtech products.



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NT24L50 and NT28L52 KYEC Test Site Correlation

KYEC Test Facility Correlation

Revision History

Version	ECO	Date	Modifications / Changes
1.0	ECO-047117	4 th Jun 2019	Initial Release

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1 Process Changes

1.1 Process Change Summary

This report details the correlation analysis and process verification performed to qualify the move of iFlex Wafer Probe test by KYEC from the HSin Chu to the Chu Nan facility

The tester platforms, software and test coverage will remain the same.

1.2 Qualification Approach

1.2.1 SAMPLING

Sample of 50 die of each of the NT24L50 and NT28L52 devices are used for qualification.

1.2.2 PROCEDURE

- 1. The 50 serialized samples are loop tested on the Reference Test System at KYEC at Hsin-Chu with a production test board and test program.
- 2. Repeat items #1 and #3 above on the same Test System using the same device samples and sequence once moved to Chu Nan
- 3. The test data is then compared to ensure tester-to-tester correlation.
- 4. Large quantity devices are tested after initial data analysis to verify the performance before completion the qualification process.

PRODDOC020200

Correlation Analysis 2

Basic statistics consisting of mean and standard deviation are calculated for each parameter on each test system. A one-to-one comparison is then made for each parameter. A visual verification of the individual test histograms is done to ensure consistent distributions.

2.1 Means Comparison

For the means comparison, acceptance is achieved if the mean value from the New Test System is within 10% of the mean value from the Reference Test System as it relates to the guard-banded test boundaries. The calculated value

 $\overline{X}_{NEW} = \overline{X}_{DEE}$ is as follows:

$$\frac{|X_{NEW} - X_{REF}|}{|T_{high} - T_{low}|} \le 10\%$$

RESULTS 2.1.1

Table 2.1: Mean Comparison Summary

NT24L50		
Test Suite	Mean Within 10%	
Continuity	Yes	
DC Bias Voltages	Yes	
Imon	Yes	
Current Consumption	Yes	
Output Termination	Yes	
Test Points	Yes	
Gain	Yes	

NT28	152
11120	DLJZ

Test Suite	Mean Within 10%
Continuity	Yes
DC Bias	Yes
Imon	Yes
Current Consumption	Yes
Output Termination	Yes
Test Points	Yes
Gain	Yes

2.2 StdDev Comparison

For the standard deviation comparison, acceptance is achieved if the standard deviation from the New Test System is within 10% of the standard deviation from the Reference Test System as it relates to the guard-banded test

boundaries. The calculated value is as follows:

$$\frac{\left|\sigma_{\scriptscriptstyle NEW} - \sigma_{\scriptscriptstyle REF}\right|}{T_{\scriptscriptstyle high} - T_{\scriptscriptstyle low}} \le 10\%$$

2.2.1 RESULTS

Table 2.2: Standard Deviation Comparison Summary

Test Suite	SD Within 10%	
Continuity	Yes	
DC Bias Voltages	Yes	
Imon	Yes	
Current Consumption	Yes	
Output Termination	Yes	
Test Points	Yes	
Gain	Yes	

NT28L52		
Test Suite	SD Within 10%	
Continuity	Yes	
DC Bias	Yes	
Imon	Yes	
Current Consumption	Yes	
Output Termination	Yes	
Test Points	Yes	
Gain	Yes	

NT24L50

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2.3 Large Sample

A larger sample of die from each device was also ran to verify that there were no issues that would appear in a production environment. The same devices were tested at both facilities. The Bin results and parametric comparisons are shown below

2.3.1 BIN RESULTS

N124L50 Bin Comparison		
Bin	Hsin Chu	Chu Nan
1	1324	1320
5	1	1
6	0	2
9	0	1
15	1	1
Total	1326	1325

Table 2.3: Bin Comparison

NT24L50 Bin Comparison

NT28L52 Bin Comparison

Bin	Hsin Chu	Chu Nan
1	1283	1281
6	0	2
8	1	1
15	1	1
Total	1285	1285

2.4 Results Discussion

Difference in binnings have been seen to be either continuity, termination resistance or marginal shifts in voltage measures. These are generally seen as contact issues with probe needles. Deltas are less than 0.5%.

3 Conclusion

Based on the analysis described in this document the correlation between the 2 facilities is acceptable.

Contact Information

Semtech Corporation 200 Flynn Road, Camarillo, CA 93012 Phone: (805) 498-2111, Fax: (805) 498-3804 www.semtech.com

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